



EP 2856  
**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Minoru KATAYAMA et al.

Application No.: 09/690,590 ✓

Filed: October 18, 2000

Group Art Unit: 2856

Examiner: M. Cygan

Docket No.: 107612

RECEIVED  
#12/C  
Haden  
7/19/02  
JUL 11 2002  
TECHNOLOGY CENTER 2800

For: SURFACE TEXTURE MEASURING MACHINE, LEVELING DEVICE FOR  
SURFACE TEXTURE MEASURING MACHINE AND ORIENTATION-ADJUSTING  
METHOD OF WORKPIECE OF SURFACE TEXTURE MEASURING MACHINE

AMENDMENT UNDER 37 C.F.R. §1.111

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

In reply to the Office Action mailed April 22, 2002, please amend the  
above-identified application as follows:

IN THE DRAWINGS:

Please correct Figures 17 and 18 as set forth in the attached Request for Approval of  
Drawing Corrections.

IN THE SPECIFICATION:

Page 1, lines 19-21, delete current paragraph and insert therefor:

9/  
Conventionally, a form measuring instrument for measuring surface roughness or  
profile of a workpiece having cylindrical shape, conic shape etc. is known. Figs. 17 and 18  
show example workpieces of the related art (Japanese Patent Laid-Open Publication  
No. Hei 8-29153 to Fukuda).